

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 16, 2025

IGI Report Number

LG700507754

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

PRINCESS CUT

Measurements

6.35 X 6.29 X 4.32 MM

GRADING RESULTS

Carat Weight

1.51 CARAT

Color Grade

G

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

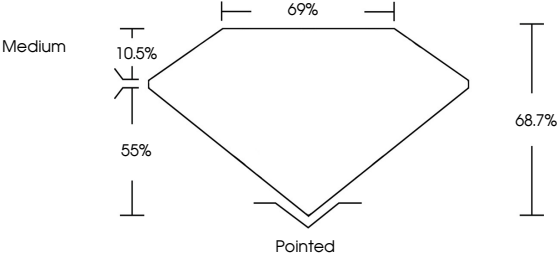
Inscription(s)

 LG700507754

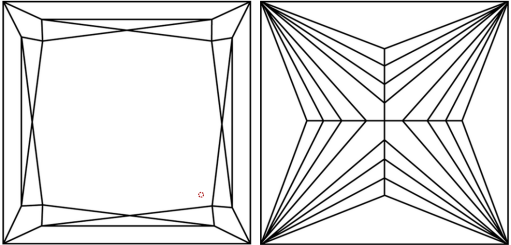
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS




CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR


D E F G H I J Faint Very Light Light

CLARITY

IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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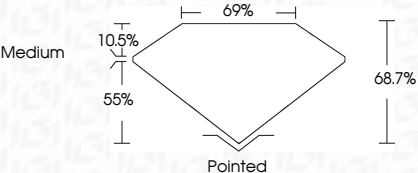
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PRINCESS CUT

6.35 X 6.29 X 4.32 MM

Carat Weight

1.51 CARAT

Color Grade

G

Clarity Grade

VVS 2

Depth

68.7%

Table

6%

Girdle

Medium

Culet

Pointed

Polish

EXCELLENT


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